

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Application of :  
Toshio KODAMA et al. :  
Serial No. (not yet assigned) :  
Filed: January 11, 2005 :  
For: ION BEAM APPARATUS, AND :  
ION BEAM PROCESSING :  
METHOD, AND HOLDER :  
MEMBER : Docket No. S004-5433 (PCT)

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**PRELIMINARY AMENDMENT CANCELING  
CLAIMS TO REDUCE FILING FEE**

S I R:

Applicants preliminarily amend their application  
before calculation of the filing fee as follows:

**BY EXPRESS MAIL ON JANUARY 11, 2005 (EV 504 368 240 US)**